

**Notice of References Cited**

Application/Control No.

10/826,877

Applicant(s)/Patent Under  
Reexamination  
HORST ET AL.

Examiner

CHIA-YI LIU

Art Unit

4172

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*	B	US-2003/0236737	12-2003	Kemp et al.	705/37
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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